

Docket No.: 5016-0102PUS1  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re Patent Application of:  
Tadahiro OHMI et al.

Application No.: 10/558,934

Confirmation No.: 6405

Filed: December 2, 2005

Art Unit: 2871

For: SUBSTRATE AND METHOD OF  
MANUFACTURING THE SAME

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Examiner: D. D. Luong

**REPLY TO RESTRICTION REQUIREMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the Restriction Requirement dated July 29, 2008, the following remarks are respectfully submitted in connection with the above-identified application.

This reply includes: Remarks